



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

October 24, 2024	
IGI Report Number	LG655432499
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	PRINCESS CUT
Measurements	6.50 X 6.47 X 4.39 MM

GRADING RESULTS

Carat Weight	1.67 CARAT
Color Grade	D
Clarity Grade	VVS 2

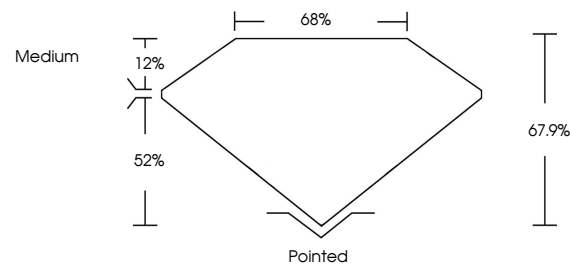
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG655432499

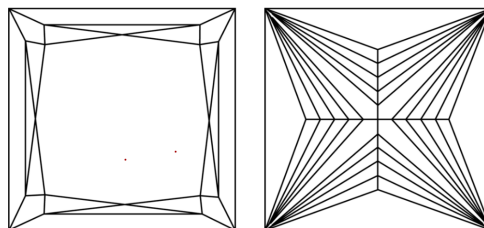
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG655432499
Report verification at igi.org

PROPORTIONS

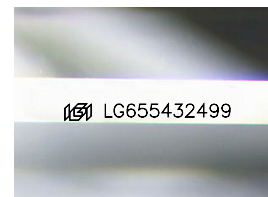


CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

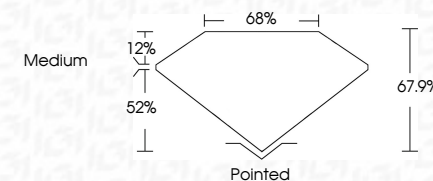
CLARITY

IF	VS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

October 24, 2024
 IGI Report No LG655432499
 PRINCESS CIT

1.67 CARAT	VS 2	67.9%	68%	Medium	Pointed	EXCELLENT	EXCELLENT	NONE	None
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